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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/686,366	10/14/2003	Tomohiko Horiguchi	PI26US	6711

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CASELLA & HESPOS
274 MADISON AVENUE
NEW YORK, NY 10016

EXAMINER

DAVIS, ROBERT B

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Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.



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1-23-08

In re Application of	:	
Tomohiko Horiguchi et al.	:	WITHDRAWAL
Serial No. 10/686,366	:	FROM ISSUE
Filed: October 14, 2003	:	UNDER 37 CFR 1.313(b)

**For: AMPUTATED PART HOLDING APPARATUS AND METHOD FOR MAKING
MOULD OF AMPUTATED PART:**

The above-identified application is withdrawn from issue after payment of the issue fee because of unpatentability of one or more claims. See 37 CFR 1.313 (b).

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon written request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to Richard Crispino at 571-272-1226.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including notifying applicant of the new status of this application.

Jacqueline M. Stone

Jacqueline Stone, Director
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